

Notice of References CitedApplication No.
08/994,038Applicant(s)
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	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS
A	5,824,235	10/20/98	Shunpei Yamazaki et al.	216	23
B	5,569,936	10/29/96	Hongyong Zhang et al.	257	57
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I					
J					
K					
L					
M					

FOREIGN PATENT DOCUMENTS

	DOCUMENT NO.	DATE	COUNTRY	NAME	CLASS	SUBCLASS
N						
O						
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Q						
R						
S						
T						

NON-PATENT DOCUMENTS

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U	Schoenfeld et al., Crystallization of amorphous silicon by NiSi sbu 2 precipitates, Thin Solid Films, pp236-240	6/95
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